Page 1 of 1 Docket No.: MICRON.278A

# OCT 2 5 2005

# Please Direct All Correspondence to Customer Number 20995

### AMENDMENT / RESPONSE TRANSMITTAL

**Applicant** 

Smythe, et al.

App. No

10/782,997

Filed

February 19, 2004

For

SUB-MICRON SPACE LINER AND

**DENSIFICATION PROCESS** 

Examiner

Christy L. Novacek

Art Unit

2822

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

October 20, 2005

Tiffany\Miller, Reg. No. 5

#### Mail Stop Amendment

Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Transmitted herewith for filing in the above-identified application are the following enclosures:

- Response to Restriction Requirement in 2 pages. (X)
- Return prepaid postcard. (X)
- Please charge any additional fees, including any fees for additional extension of (X) time, or credit overpayment to Deposit Account No. 11-1410.

Tiffany Miller

Registration No. 52,032

Attorney of Record Customer No. 20,995

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IJW

**PATENT** 

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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October 20, 2005

(Date)

iffany Miller, Reg. No. 52,032

## RESPONSE TO RESTRICTION REQUIREMENT

#### Mail Stop Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

#### Dear Sir:

)

In response to the Office Action dated September 23, 2005, Applicant submits the following remarks for consideration in connection with the above-identified patent application.